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**FROM:** Keith M. Tackett  
**PAGE(S) with cover:** 11  
**ORIGINAL TO FOLLOW?**  YES  NO

### RESPONSE TO FINAL OFFICE ACTION DATED DECEMBER 20, 2005

**TITLE:** Method and Apparatus for Infilm Defect Reduction for Electrochemical Copper Deposition  
**U.S. SERIAL NO.:** 10/774,194  
**FILING DATE:** February 5, 2004  
**INVENTOR:** Huang  
**EXAMINER:** Quovaunda Jefferson  
**GROUP ART UNIT:** 2823  
**CONFIRMATION NO.:** 6951

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